

Our Ref.: 3008-0034
File No.: 521.41463X00
Client Ref.: PHCF-01103



PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
OKA, et al.

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: Art Unit: 2811
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: Examiner: S. Hu
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Application S/N 09/925,626

Filed: August 10, 2001

For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE,
CRYSTALLINE SILICON FILM PHOTOVOLTAIC DEVICE, AND PROCESS
FOR PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR
DEVICE

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 13, 2004

Sir:

Applicants note that an Interview Summary accompanied the Notice of Allowance and confirm that the undersigned attorney conducted a telephone interview with the Examiner, on June 7, 2004, during which time amendments to the claims were discussed and authorized in order to place the application in condition for allowance. Thus, applicants confirm the substance of the interview as provided by the Interview Summary and although applicants consider the submission of this paper to be unnecessary, to avoid any question concerning the requirements for applicant to file a statement of the substance of the interview, this statement is submitted.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

Sterling W. Chandler
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SWC/slk